



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of	I hereby certify that this correspondence is being deposited with the United States Postal Service as first
Yamazaki et al.	class mail in an envelope addressed to: Commissioner for Patents,
Serial No.: 09/993,993.	P.O. Box 1450, Alexandria, VA 22313-1450 on Softmoor 3, 2003
Filed: November 14, 2001	(Date of Deposit) Shannon Wallace
For: Semiconductor Device And Method) Of Manufacturing The Same)	Name of applicant, assignee, or Registered Rep. Signature Date
Art Unit: 2826)	1000
Examiner: T. Pham	RECT
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	1 203
AMENDME! Sir:	25

In response to the Office Action dated June 3, 2003, please amend the above-identified application as follows:

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